



PATENT
Customer No. 22,852
Attorney Docket No. 04329.2306

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Yoshio Ozawa, et al.) Group Art Unit: 2823
Application No.: 09/559,757) Examiner: Pham, Thanh V.
Filed: April 27, 2000)
For: METHOD OF MANUFACTURING)
A SEMICONDUCTOR DEVICE)
USING AN OXIDATION)
PROCESS)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT
UNDER 37 C.F.R. § 1.97(b)

Pursuant to 37 C.F.R. §§ 1.56 and 1.97(b), Applicants bring to the attention of the Examiner the documents listed on the attached PTO 1449. Applicants submit this Supplemental Information Disclosure Statement (IDS) together with a Request for Continued Examination (RCE) for the above-identified application. This Supplemental IDS is being filed in addition to IDS filed April 27, 2000 and the IDS filed March 29, 2004.

Applicants attach a copy of each of the listed documents. Applicants respectfully request that the Examiner consider the listed documents and indicate their consideration by making appropriate notation on the attached PTO-1449 form.

The documents listed in this Supplemental Information Disclosure Statement were first cited in an Office Action mailed by the Japanese Patent Office on May 18, 2004 in counterpart foreign Application No. 2000-122018.

Copies of the listed documents are enclosed. In lieu of a statement of relevance or translation of the non-English documents, an English language version of the Office Action citing those documents and setting forth the relevance thereof, is enclosed. Applicants do not necessarily endorse the conclusions set forth in the Office Action. Applicants have also enclosed a copy of the Office Action for the Examiner's convenience.

Applicants respectfully request that the Examiner consider the listed documents and indicate their consideration by making appropriate notation on the attached PTO-1449 form.

Applicants point out that Japanese Patent Application No. 8-250720 cited in the attached Japanese Patent Office Action was previously submitted to the U.S. Patent and Trademark Office with the IDS filed on March 29, 2004. Thus, Applicants have not listed this document on the attached form PTO-1449.

This submission does not represent that a search has been made or that no better art exists and does not constitute an admission that each or all of the listed documents are material or constitute "prior art." If the Examiner applies any of the documents as prior art against any claims in the application and Applicants determine that the cited documents do not constitute "prior art" under United States law, Applicants reserve the right to present to the Office the relevant facts and law regarding the appropriate status of such document.

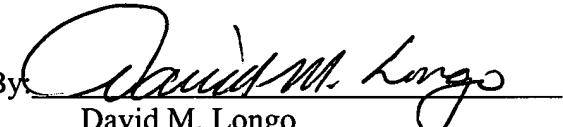
Applicants further reserve the right to take appropriate action to establish the patentability of the disclosed invention over the listed documents, should one or more of the documents be applied against the claims of the present application.

If there is any fee due in connection with the filing of this Statement, please charge the
fee to our Deposit Account No. 06-0916.

Respectfully submitted,

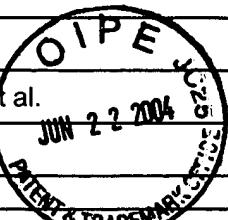
FINNEGAN, HENDERSON, FARABOW,
GARRETT & DUNNER, L.L.P.

Dated: June 22, 2004

By 
David M. Longo
Reg. No. 53,235

INFORMATION DISCLOSURE CITATION

Atty. Docket No.	04329.2306	Appln. No.	09/559,757
Applicant	Yoshio Ozawa, et al.		
Filing Date	April 27, 2000	Group:	2823



U.S. PATENT DOCUMENTS						
Examiner Initial*	Document Number	Issue Date	Name	Class	Sub Class	Filing Date If Appropriate

FOREIGN PATENT DOCUMENTS						
	Document Number	Publication Date	Country	Class	Sub Class	Translation Yes or No
	7-183513	7/1995	Japan			No
	10-223771	10/1998	Japan			No
	9-148543	6/1997	Japan			No
	10-163197	6/1998	Japan			No
	10-32328	2/1998	Japan			No

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)	
	Copy of Office Action, dated May 14, 2004, in Japanese Patent Application No. 2000-122018, and English-language translation.

Examiner	Date Considered
*Examiner:	Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.
Form PTO 1449	Patent and Trademark Office - U.S. Department of Commerce